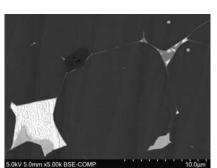






Ease of use and Throughput:

Innovative "EM Wizard" GUI offers point-and-click optimized imaging. Groundbreaking computer-assisted technology offers a new level of SEM operation and control.



Specimen : Ferrite core

Surface information

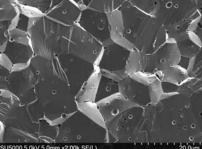
Visual and interactive guide offers "Observation purpose" to ensure best operating conditions.

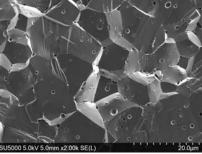
Furthermore, automated optical axis alignment and astigmatism correction raise user-friendliness to a new level.

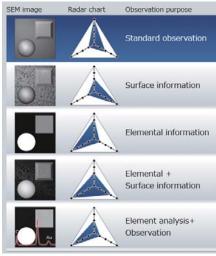
Expert or novice, the result is now the same



Specimen: Neodymium magnet





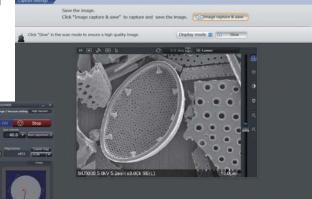


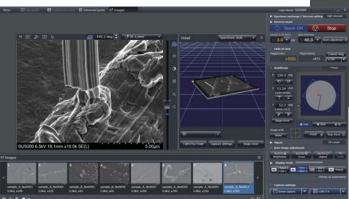
*above table : BSD fitted configuration. BSD is option.



Intuitive user interface

Standard mode offers simple and quick operation. Novice users are guided step by step and learn along the way thanks to the interactive user guide.





Advanced mode has full functionality which displays multiple signals, provides advanced 3D stage navigation using low mag SEM images, and safely executes complex tilt and rotation stage moves with "3D Multifinder". 3D Multifinder also safely and precisely positions the sample's FOV for EBSD analysis.

Hitachi SU5000 FE-SEM

High performance optics:

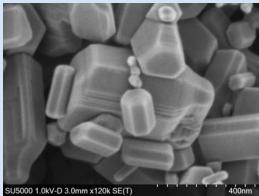
- Resolution In-column Top Detector (2.0 nm at 1 kV).
- Sensitivity Ultra efficient photodiode BSE Detector, unmatched Low kV imaging to 100 V, and high probe current (>200 nA) for efficient microanalysis.

Robust Performance:

- Variable Pressure Unparalleled low vacuum (10-300 Pa) imaging with the novel Ultra Variable pressure Detector (UVD).
- Quick and easy specimen exchange via stage drawer (Max. sample size: 200 mm dia. x 80 mmH).
- Microanalysis EDS, WDS and EBSD, etc

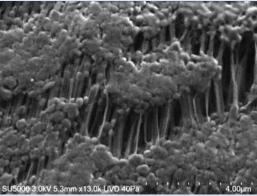


Application data



Sample: Zinc Oxide powder V-land: 1 kV, Mag.: 120,000x

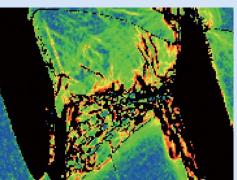
High resolution TOP detector image obtained at low kV (1 kV)



Sample: PTFE Vacc: 3 kV, Mag.: 13,000x UVD providing high quality image at low kV (3 kV) and

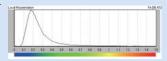
low vacuum (40 Pa)





Vacc:15 kV lp:8 nA Step:0.1 μm

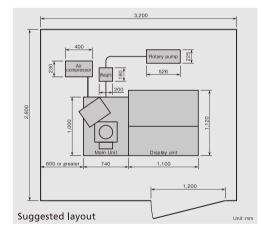
Sample: Heat resistant steel Vacc: 15 kV
New 5-segment PD-BSE demonstrating high orientation contrast image at low take-off angle (left). The correlative grain misorientation map acquired through EBSD (right), showing contrast precision corresponding to 0.5 degree misorientation.



Main specifications

Spatial Resolution			1.2 nm @ 30 kV 3.0 nm @ 1 kV 2.0 nm @ 1 kV with deceleration mode *1 3.0 nm @ 15 kV Variable Pressure mode *2
Magnification			10~600,000x (based on 4 "x 5 "picture), 18~1,000,000x (800x600 pixels on display)/30~1,500,000x (1,280x960 pixels on display)
Electron Optics	Emitter		ZrO/W Schottky emitter
	Acceleration Voltage		0.5~30 kV (0.1 kV step)
	Landing Voltage		0.1~2.0 kV with deceleration mode*1
	Maximum Probe Current		> 200 nA
Detector			Evehart Thonley SE detector (Lower detector)
Variable Pressure Mode *2			Pressure Range:10~300 Pa
Specimen Stage	Control		5-Axis motorized stage
	Movement	Х	0~100 mm
		Υ	0~50 mm
		Z	3∼65 mm
		Т	-20~90 °
		R	360 °
	Specimen Size		up to 200 mm $arphi$
			maximum 80 mm height
Monitor *3			23 inch LCD (1920×1080)
Display Mode	Large screen display		1,280×960 pixels
	Single image display		800×600 pixels
	Dual image display		640×480 pixels
	Quad image display		640×480 pixels
mage Data Saving	Pixel Size		640×480 1,280×960 2,560×1,920 5,120×3,840
Dimension and Weight	Main Unit		740(W) x 1,000(D) x 1,650(H) mm 550 kg
	Display		1,100(W) x 1,120(D) x 730(H) mm 290 kg
	Rotary Pump *3		526(W) x 225(D) x 306(H) mm 28 kg
	Air Compressor *3		400(W) x 230(D) x 520(H) mm 18 kg
	Weight		200(W) x 180(D) x 160(H) mm 40 kg
	Ultra Variable-Press Retractable five seg Energy Dispersive X Wavelength Dispers	ure De ment -ray d ive X-	Backscatter Electron Detector (PD-BSD) *4 letector (EDS)

*1: Top detector is option, combined to deceleration function. *2: Variable Pressure mode is option. *3: option *4: PD-BSD is standard detector in Variable Pressure system.



Notice: For correct operation, follow the instruction manual when using the instrument.

Specifications in this catalog are subject to change with or without notice, as Hitachi High-Tech Corporation continues to develop the latest technologies and products for our customers.

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